

IPW

In re Application of:

Docket No. 00862.023231

Hiromichi HARA

Application No.: 10/658,207

Examiner: H. Nguyen

Filed: September 10, 2003

Group Art Unit: 2851

For: EXPOSURE APPARATUS AND
METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE USING THE SAME

Confirmation No. 3252

November 15, 2004
(Monday)

Mail Stop Amendment

Commissioner For Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

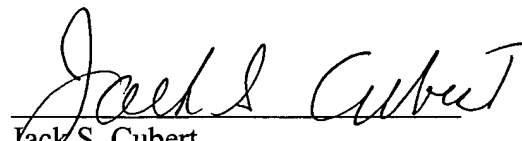
☒ No additional fee is required.

The fee has been calculated as shown below:

| CLAIMS AS AMENDED | | | | | | |
|--|--|-------|--|-------------------------|----------------|-------------------|
| | (2) CLAIMS REMAINING AFTER AMENDMENT | | (4) HIGHEST NO. PREVIOUSLY PAID FOR | (5) PRESENT EXTRA | RATE | ADDITIONAL FEE |
| TOTAL CLAIMS | 15 | MINUS | 20 | = 0 | x \$9 \$18 | 0.00 |
| INDEP. CLAIMS | 1 | MINUS | 3 | = 0 | x \$43 \$88 | 0.00 |
| Fee for Multiple Dependent claims \$150°/\$300 | | | | | | 0.00 |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT--- | | | | | | 0.00 |

- ☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$____ is enclosed.
- ☐ Charge \$____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$____ to cover the fee for a ____ month extension is enclosed.
- ☐ A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

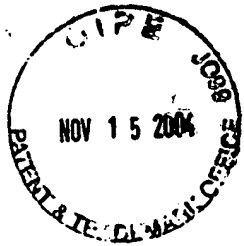
Respectfully submitted,



Jack S. Cubert
Attorney for Applicants
Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
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SEW/JSC/dc

DC_MAIN 184065v1



00862.023231

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hiromichi HARA

Application No.: 10/658,207

Filed: September 10, 2003

For: EXPOSURE APPARATUS AND METHOD OF
MANUFACTURING A SEMICONDUCTOR
DEVICE USING THE SAME

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: Examiner: H. Nguyen
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: Group Art Unit: 2851
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: Confirmation No. 3252
)
:
) November 15, 2004
: (Monday)
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Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action mailed August 13, 2004, the time for response being extended from Saturday, November 13, 2004 to Monday, November 15, 2004, please amend the above-identified application as follows: